

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
STEPHEN KEETAI PARK

Serial No.: 10/045,895

Filed: October 29, 2001

For: METHOD OF FABRICATING  
COPPER-BASED SEMICONDUCTOR  
DEVICES USING A SACRIFICIAL  
DIELECTRIC LAYER

Examiner: Hsien-Ming Lee

Group Art Unit: 2823

Att'y Docket: 2000.029996/TT3586C

RESPONSE TO OFFICE ACTION DATED AUGUST 28, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

CERTIFICATE OF TRANSMISSION  
37 C.F.R. 1.6(d)

I hereby certify that this correspondence is being transmitted to the  
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450,  
703-872-9318 on the date below:

October 02, 2003  
Date

*Kathryn Danas*  
Kathryn Danas

Sir:

This paper is submitted in response to the Office Action dated August 28, 2003, for which the three-month date for response is November 28, 2003.

It is believed that no fee is due; however, should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Assistant Commissioner is authorized to deduct said fees from **Advanced Micro Devices, Inc.'s Deposit Account 01-0365/TT3658C**.

Reconsideration of the application is respectfully requested.

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